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D/Ging
1/30/02

Docket No.: M4065.0227/P227A
(PATENT)

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re Patent Application of:
Tongbi Jiang, et al.

Application No.: To Be Assigned
Divisional of Serial No. 09/652,216

Group Art Unit: 2813

Filed: December 3, 2001

Examiner: E. Pert

For: METHOD AND APPARATUS FOR
REDUCING SUBSTRATE BIAS VOLTAGE
DROP

FIRST PRELIMINARY AMENDMENT

Commissioner for Patents
Washington, D.C. 20231

Dear Sir:

Prior to examination on the merits, please amend the above-identified U.S.
patent application as follows:

4003370660